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## APPLICANTS

Shigeki Imai, Nara-shi, JAPAN;  
 Kazuhiko Inoguchi, Nara-shi, JAPAN;  
 Hikaru Kobayashi, Kyoto-shi, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP05/02352 02/16/2005

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2004-038888 02/16/2004  
 JAPAN 2004-093703 03/26/2004  
 JAPAN 2004-093695 03/26/2004

## \*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

02/09/2007

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input checked="" type="checkbox"/> Met after Allowance PD Initials	JAPAN	26	34

## ADDRESS

NIXON & VANDERHYE, PC  
 901 NORTH GLEBE ROAD, 11TH FLOOR  
 ARLINGTON, VA 22203  
 UNITED STATES

## TITLE

THIN FILM TRANSISTOR, METHOD OF MANUFACTURING SAME, DISPLAY DEVICE, METHOD OF MODIFYING AN OXIDE FILM, METHOD OF FORMING AN OXIDE FILM, SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE

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